



# MINIATURIZATION FOR SPACE EXPLORATION

## APPLIED NANOTECHNOLOGY AND MICROSYSTEMS

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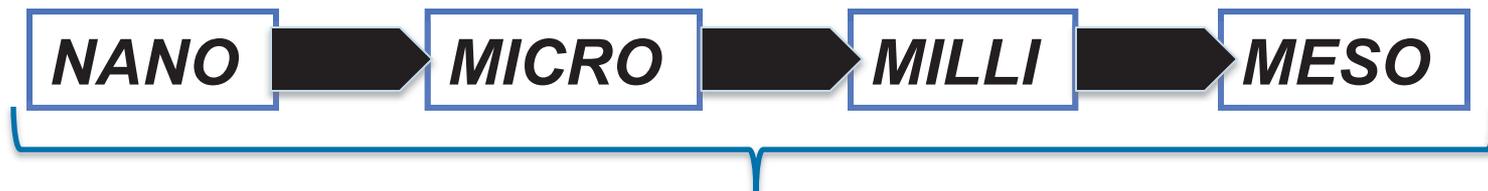
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# INTRODUCTION

- Nano and Micro Systems group charter
  - To develop application-driven micro and nano devices/ techniques for *in situ* as well as remote planetary exploration
- Application examples
  - Planetary mineralogy, Spacecraft G&N/precision pointing of instruments, Extreme environment sensors and electronics, Microimaging, Heterodyne Spectroscopy
  - Ideally related to NASA science missions (earth, planetary, astro/physics)
  - Many developments are multi-use (Space, Defense, Commercial)



Hierarchical Integration

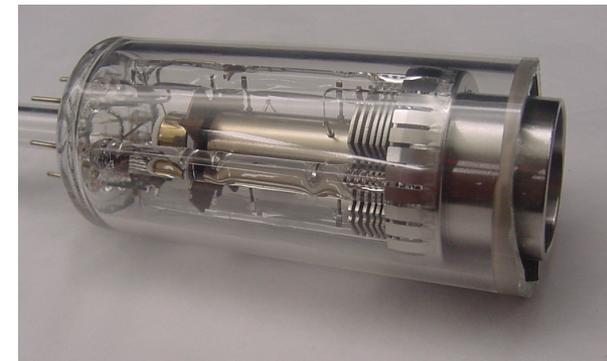


# OUTLINE

- Vacuum Microelectronics/Instruments Using CNTs
  - Field emission of electrons
  - High current density CNT bundle arrays
  - Applications
    - X-rays for Mineralogy
    - 700°C Logic Gates
- Distributed Capacitor (DisC) Sensor for Sample Verification
  - Need and rationale
  - Design and Test Results

# FIELD EMISSION OF ELECTRONS

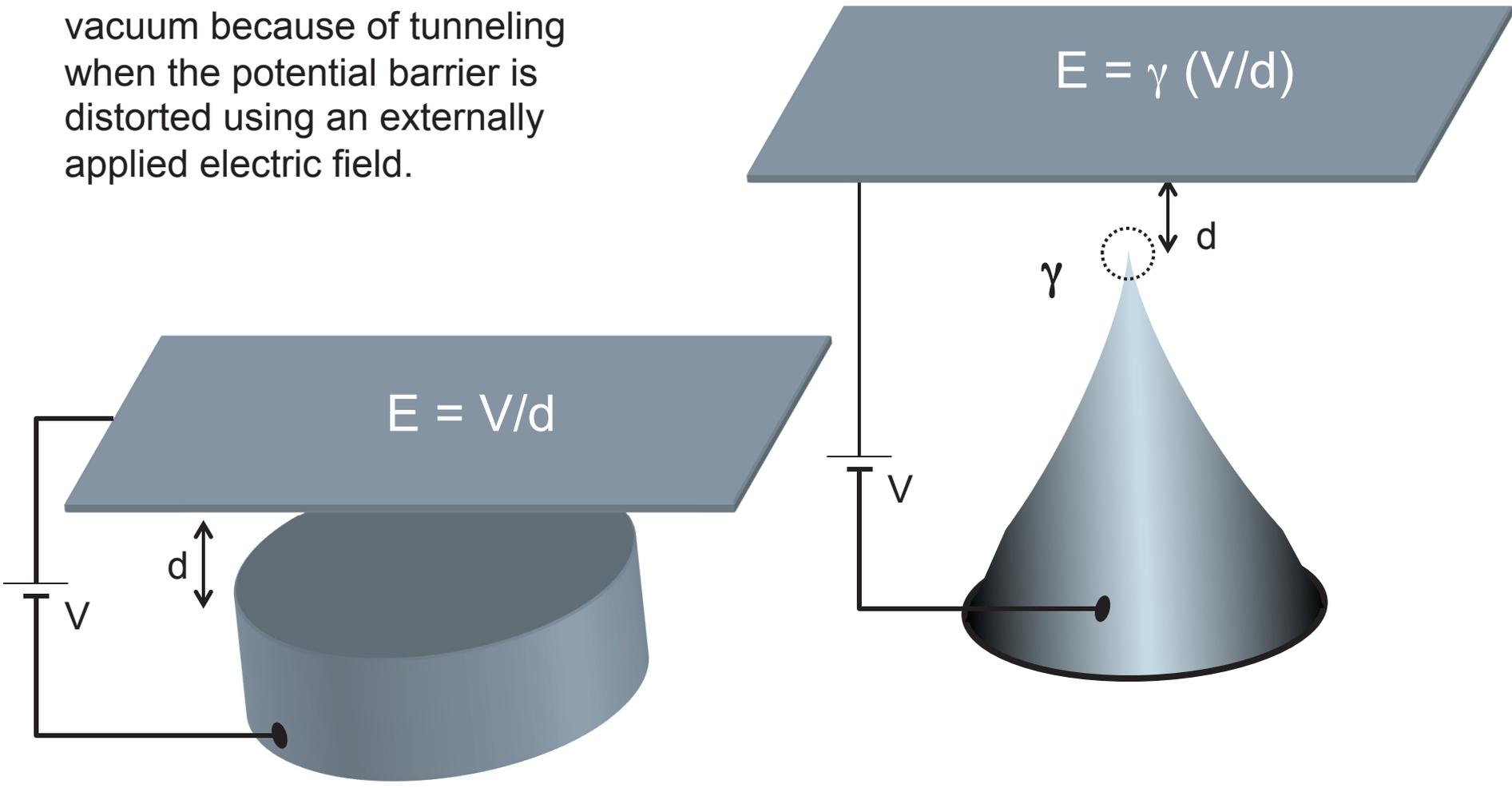
- Electron sources are fundamental components of many analytical instruments and certainly of vacuum electronic devices.
- Miniaturization of analytical instruments, for example, enables larger science payload.
- Vacuum electronics in combination with Silicon Micromachining enables miniature extreme environment components.
- Traditionally popular thermionic electron sources (boil off electrons at  $>1200^{\circ}\text{C}$ ) are power hungry, bulky, need thermal management, and are not conducive for miniaturization.
- **Cold cathodes is the answer...but which one?**



# FIELD EMISSION OF ELECTRONS

## Principle

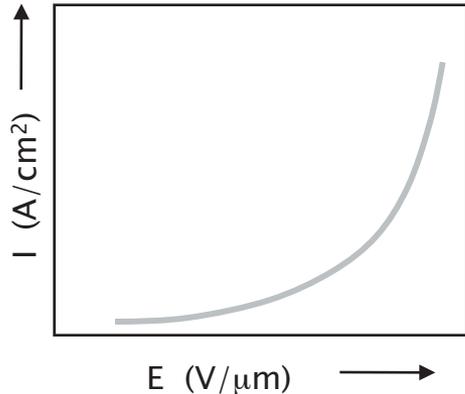
Emission of electrons into vacuum because of tunneling when the potential barrier is distorted using an externally applied electric field.



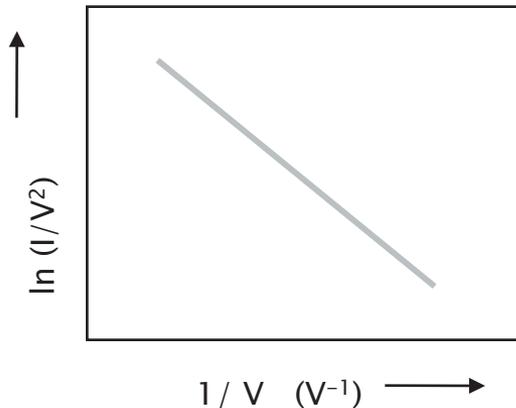
# FIELD EMISSION OF ELECTRONS

## Fowler-Nordheim Equation

I-V Curve



Fowler-Nordheim Curve



$$I = 1.54 \times 10^{-6} \frac{\gamma^2 A_{(e)}}{\phi} \cdot \left(\frac{V}{d}\right)^2 \cdot e^{\left[-6.8 \times 10^7 \cdot \frac{\phi^{3/2} \cdot d}{\gamma V}\right]}$$

$$\ln\left(\frac{I}{V^2}\right) = \ln(a) - \frac{b}{V}$$

$$I \propto \gamma^2$$

“ $\gamma$ ” is the key!

I : Emission current (A)

V: Biasing voltage (V) ; d : gap

a, b: constants

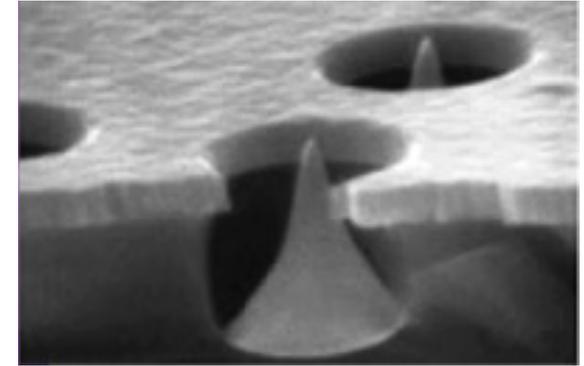
$\phi$ : Work function

$\gamma$ : Field enhancement factor

$A_{(e)}$ : Emission area

# FIELD EMISSION OF ELECTRONS

- Sharp metallic tips or metal-coated Silicon tips are commonly used cold cathodes.
- They are sensitive to poor vacuums- very short lifetimes, and tips sputter easily.
- Most miniaturization applications using cold cathodes need vacuum packaging of microcavities.

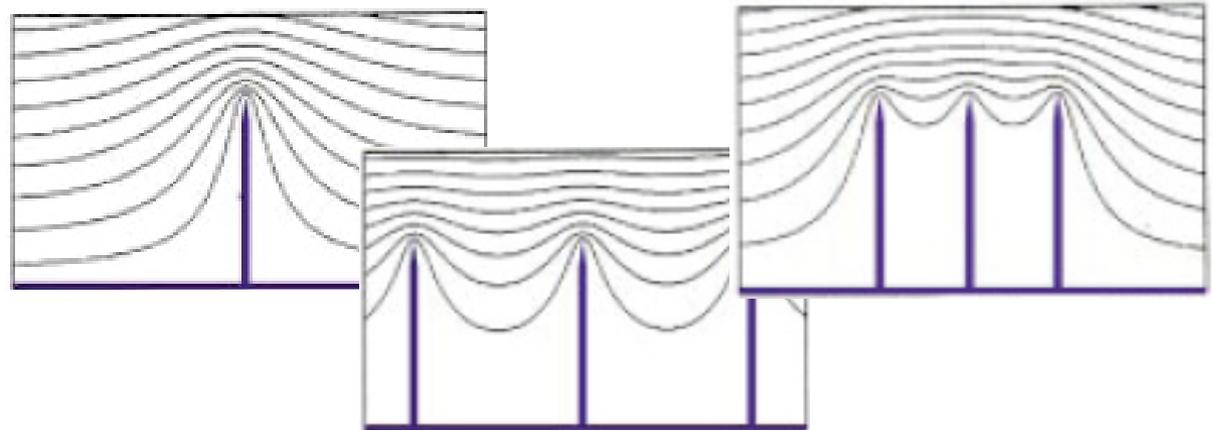


- Typical vacuums achieved is  $10^{-6}$  to  $10^{-5}$  Torr.

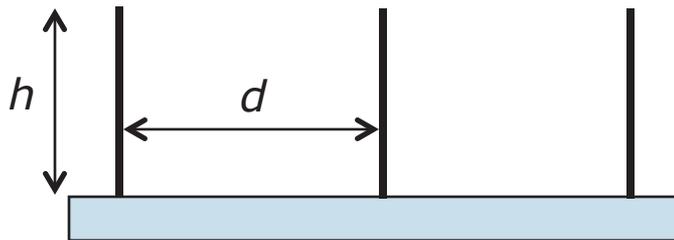
- **Carbon nanotubes seem robust to such poor vacuums- redundancy, conducive emission mechanism, ease of synthesis, low emission threshold, and higher current density per tip compared to other types of cold cathodes.**

# FIELD EMISSION OF ELECTRONS

Simulation of field penetration  
by L. Nilsson *et al*  
APL 76(15) 2071-2073 (2000)



$$I \propto \gamma^2 \Rightarrow \left\{ \begin{array}{l} \gamma \propto \text{Aspect Ratio (reciprocal of the tip radius)} \\ \gamma_S \propto \text{Reciprocal of CNT number density} \rightarrow \text{For the sample} \end{array} \right.$$



$$d = 2h \text{ (simulation)}$$

L. Nilsson *et al*, APL 76 (15), 2071-2073 (2000)

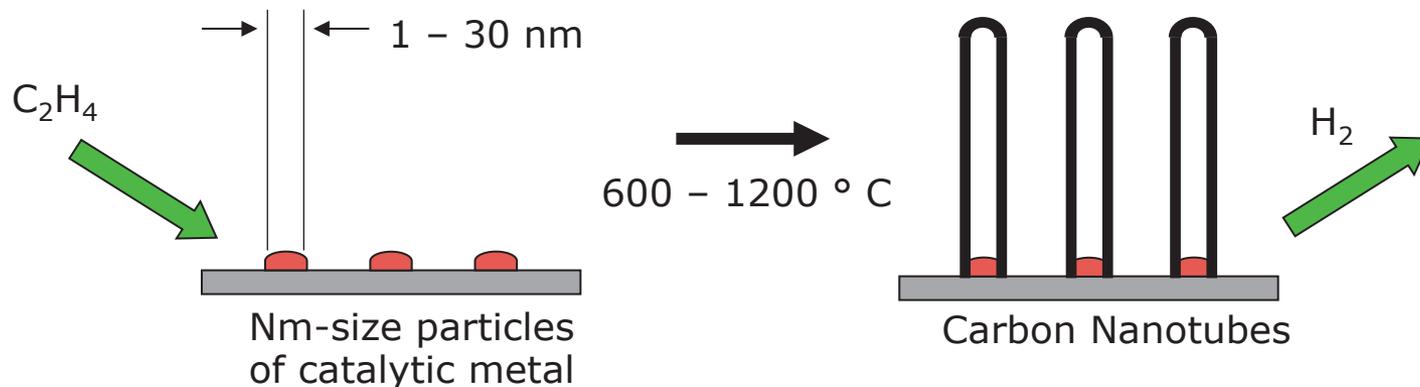
$$d = h \text{ (experiment)}$$

J.S. Suh *et al*, APL, 80, 2392-2394 (2002)

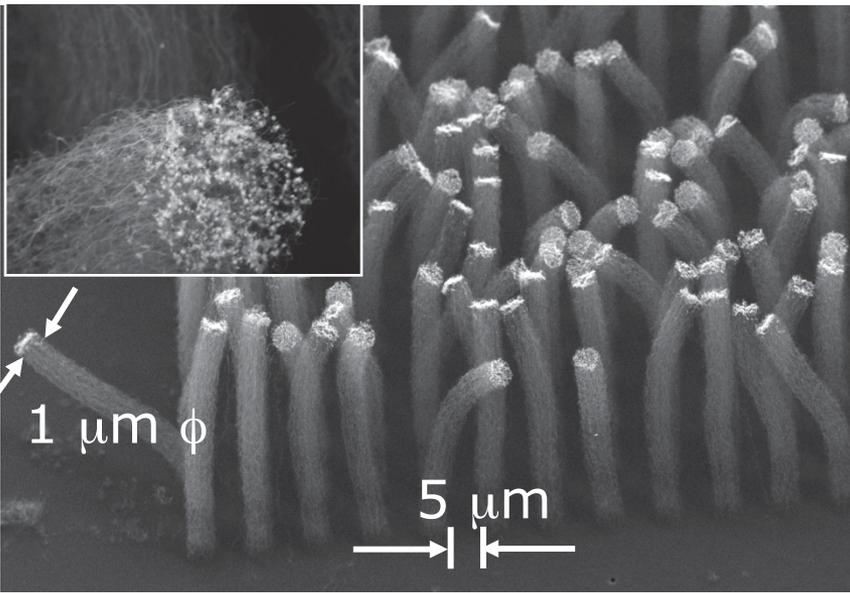
*Achieving high-current density is really an OPTIMIZATION problem.*

# FIELD EMISSION OF ELECTRONS

- High electron emission from a single CNT (30 to 100 nA) does not scale up with increased number of CNTs on a sample.
- Electrostatic screening and number density limit emission levels.
- But, CNTs are great for application in miniature systems that have poor vacuums ( $10^{-4}$  to  $10^{-5}$  Torr)
- **Optimum arrangement needed.**

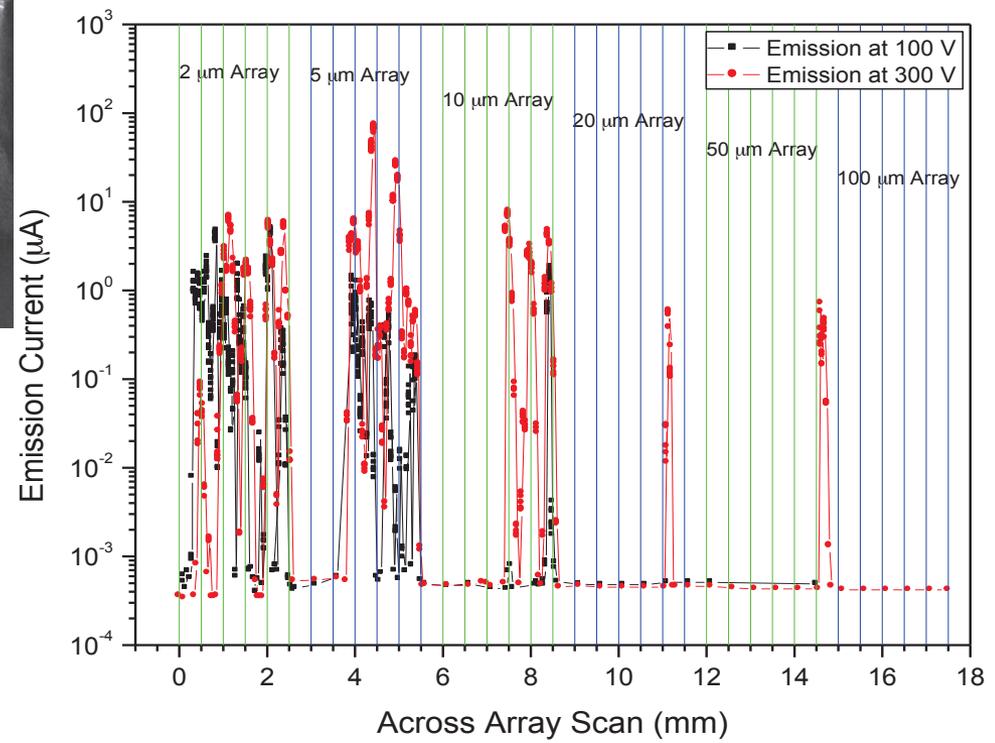


# HIGH-CURRENT DENSITY CNT BUNDLE ARRAYS



CNT bundles of 1-2  $\mu\text{m}$  diameter spaced 5  $\mu\text{m}$  edge-to-edge produced the highest field emission current.

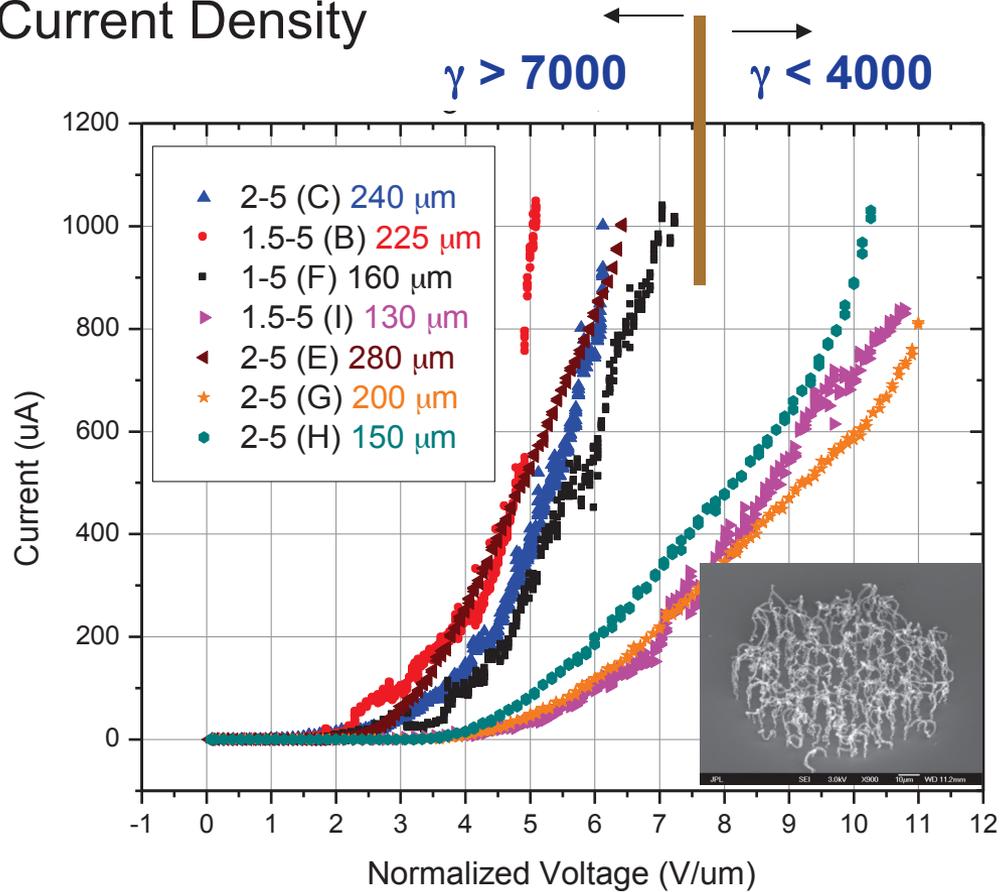
This arrangement is being used in multiple applications routinely producing 2 to 10  $\text{A}/\text{cm}^2$  current density at low fields of 4 to 8  $\text{V}/\mu\text{m}$



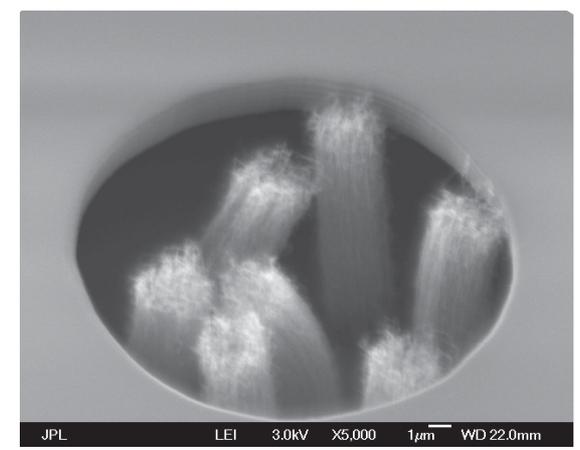
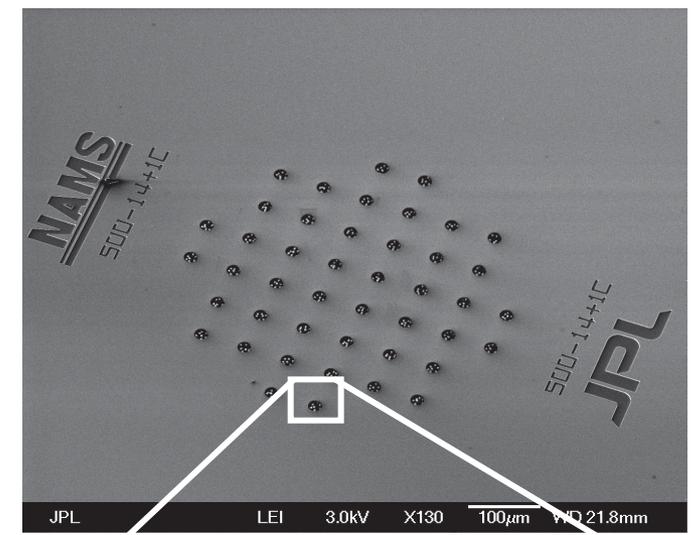
# HIGH-CURRENT DENSITY CNT BUNDLE ARRAYS



## Repeatable High Current Density



## Monolithic Gate Integration



Range of current density = **10 to 15 A/cm<sup>2</sup>**

$2 \times 10^{-5}$  Torr; 1 mA = 12.7 A/cm<sup>2</sup>; 785  $\mu\text{A}$  = 10 A/cm<sup>2</sup>

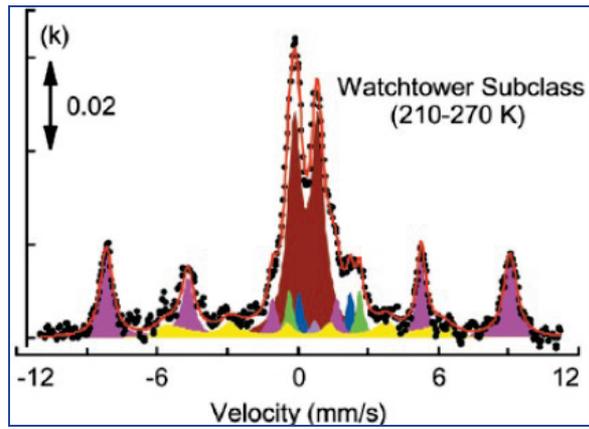
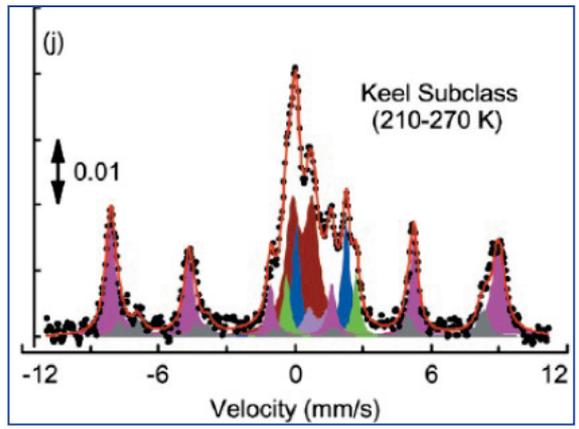
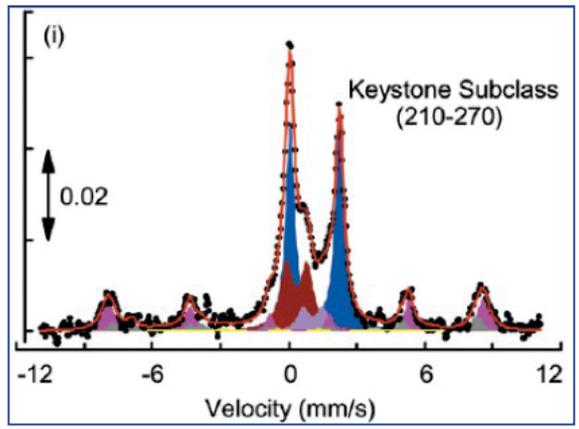
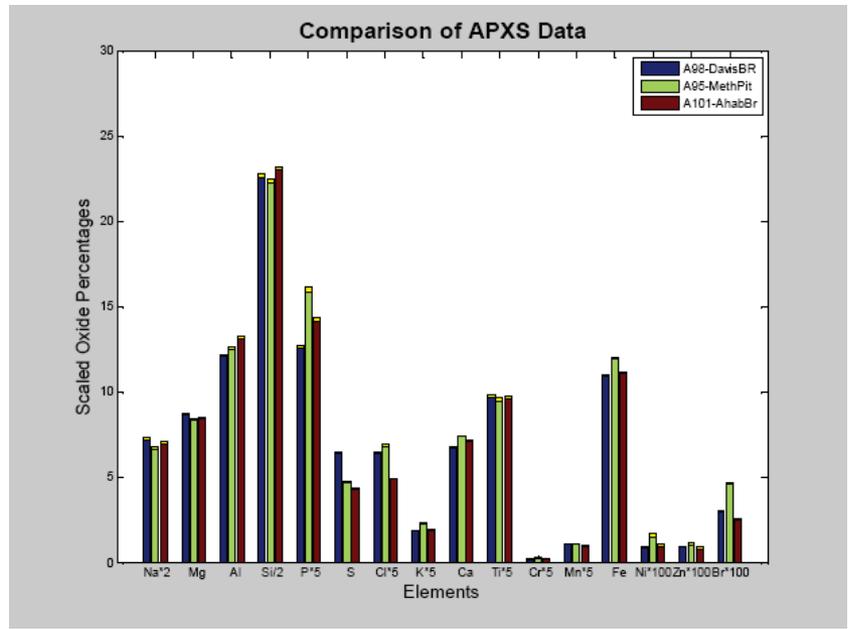
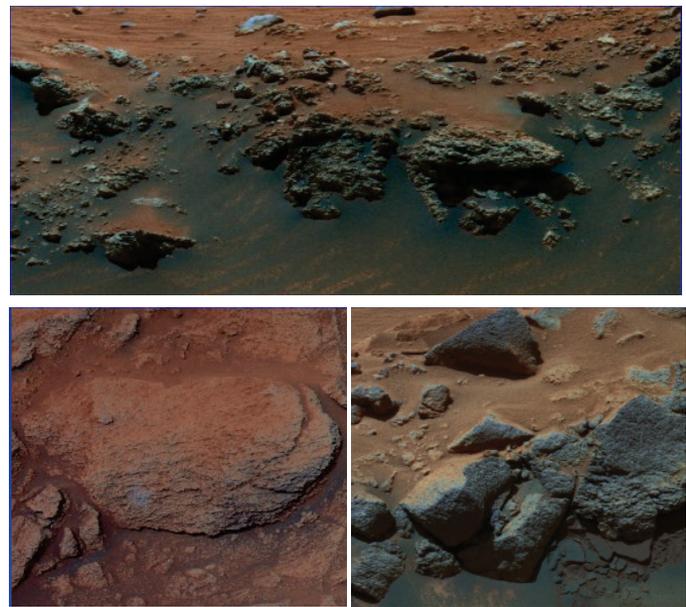


# APPLICATIONS

# APPLICATIONS: X-rays for Mineralogy



## The Importance

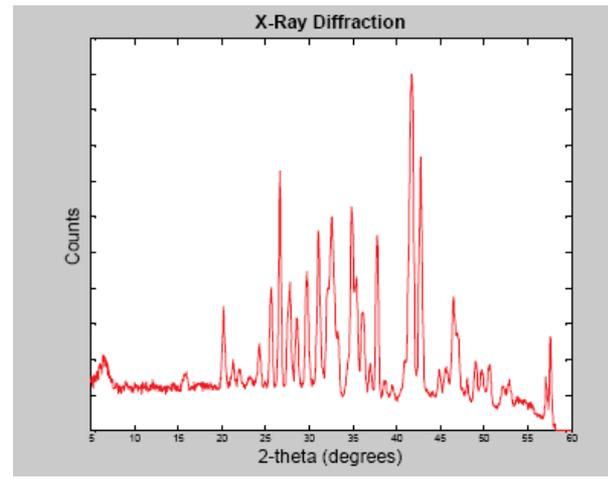
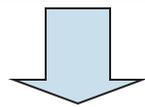
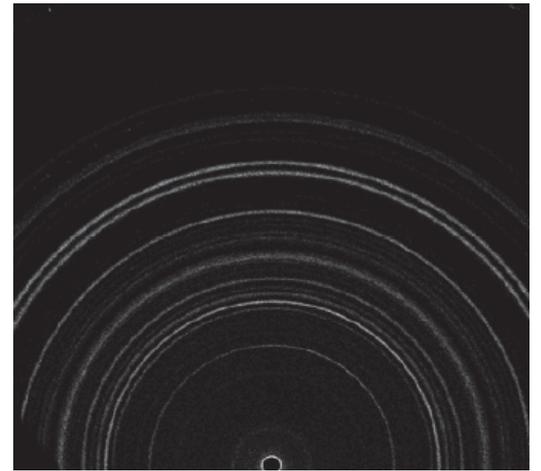
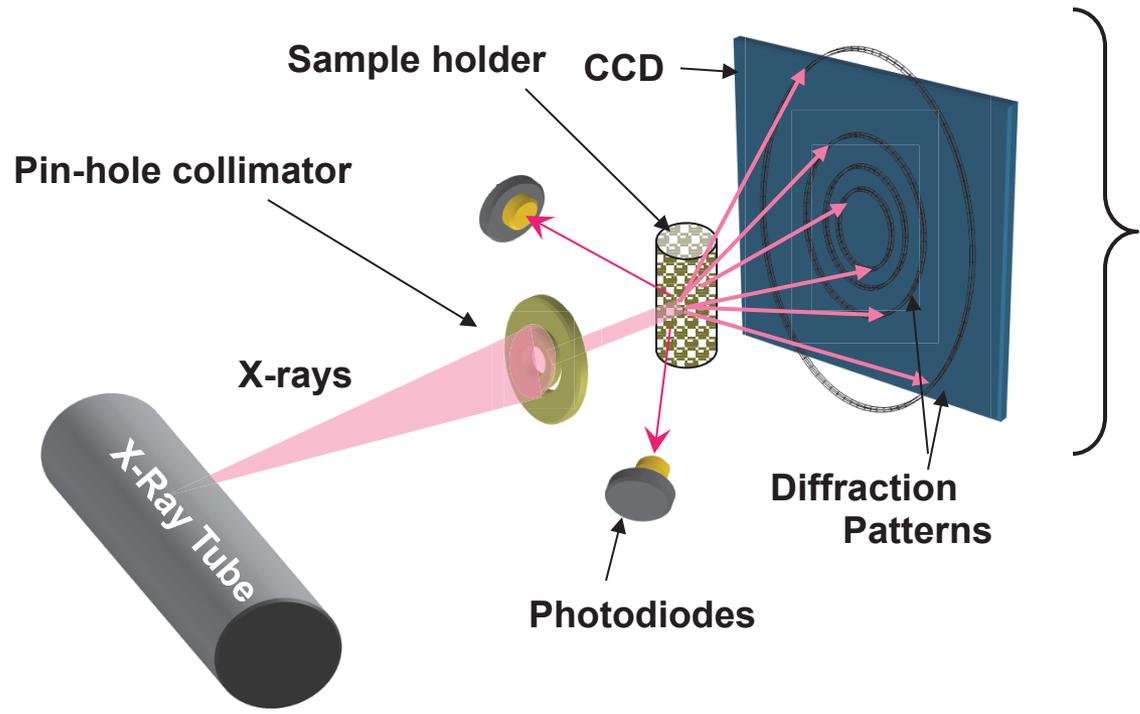


Courtesy: A. Yen (JPL)

# APPLICATIONS: X-rays for Mineralogy



## Planetary Instrument



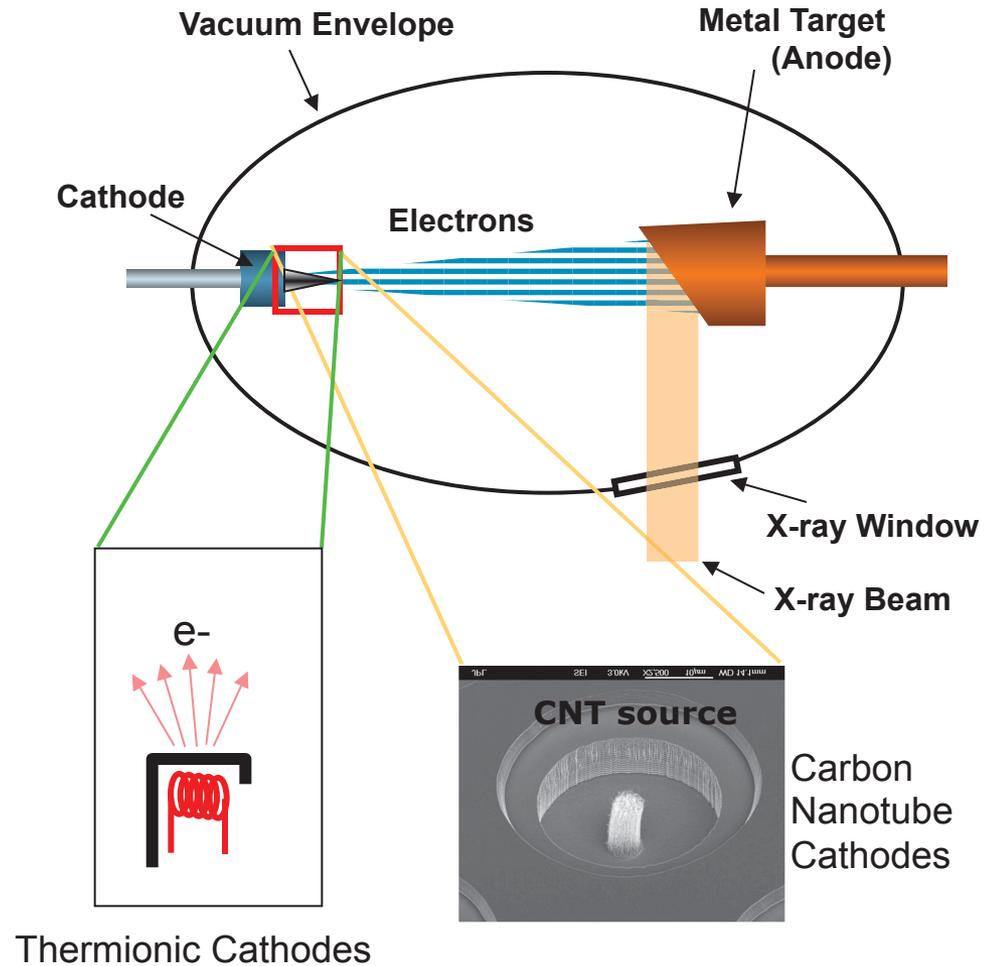
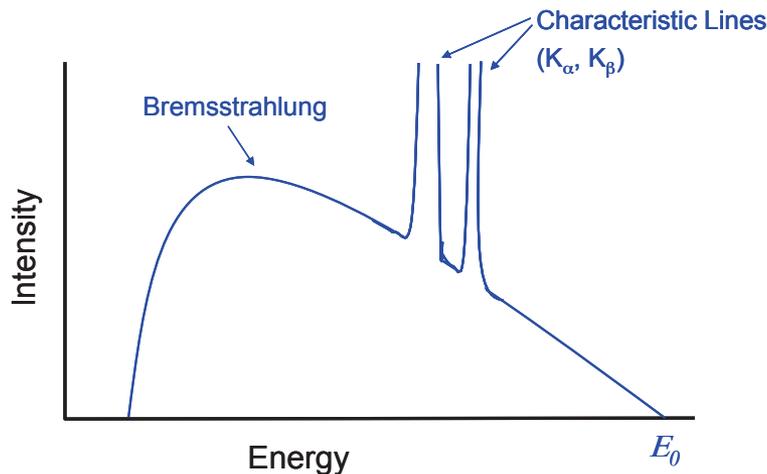
Design conceived/developed by **Dr. D. Blake et al** of NASA-Ames

Schematic is somewhat similar to the CheMin instrument on Mars Science Laboratory.

# APPLICATIONS: X-rays for Mineralogy

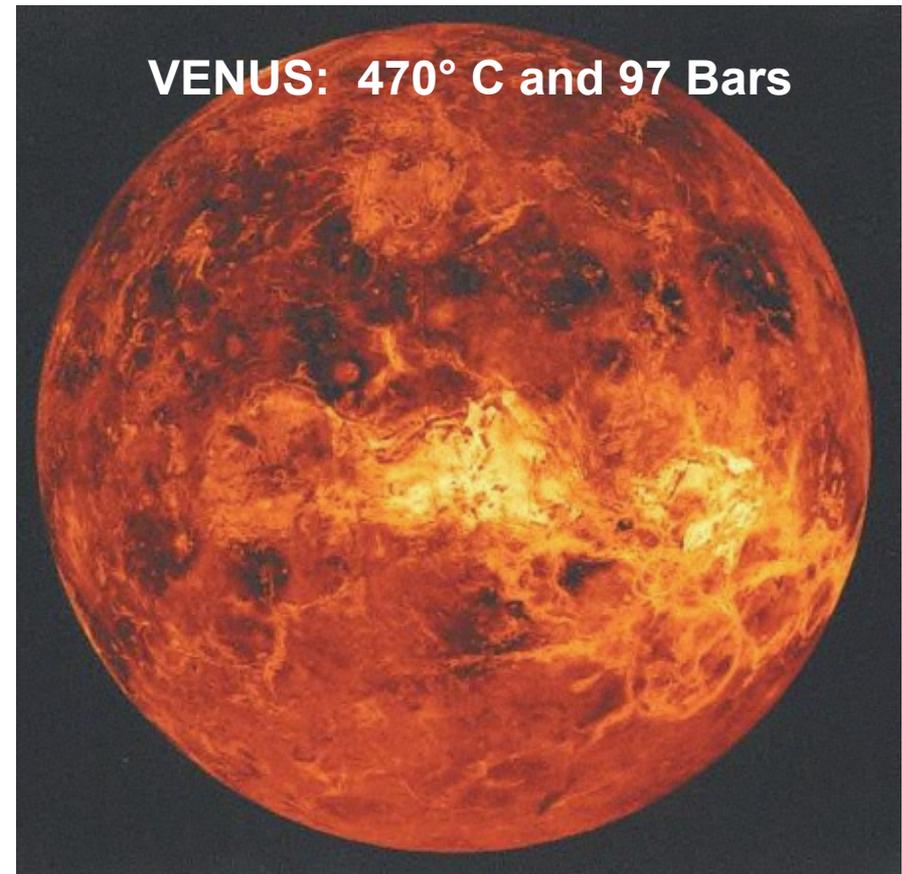
## X-Ray Based Techniques

- Accelerated electrons bombard with a metal target to produce a continuous X-ray spectrum (Bremsstrahlung) as well as characteristic X-ray lines.
- The upper limit of the Bremsstrahlung radiation energy is limited by the acceleration voltage (Duane-Hunt Law).



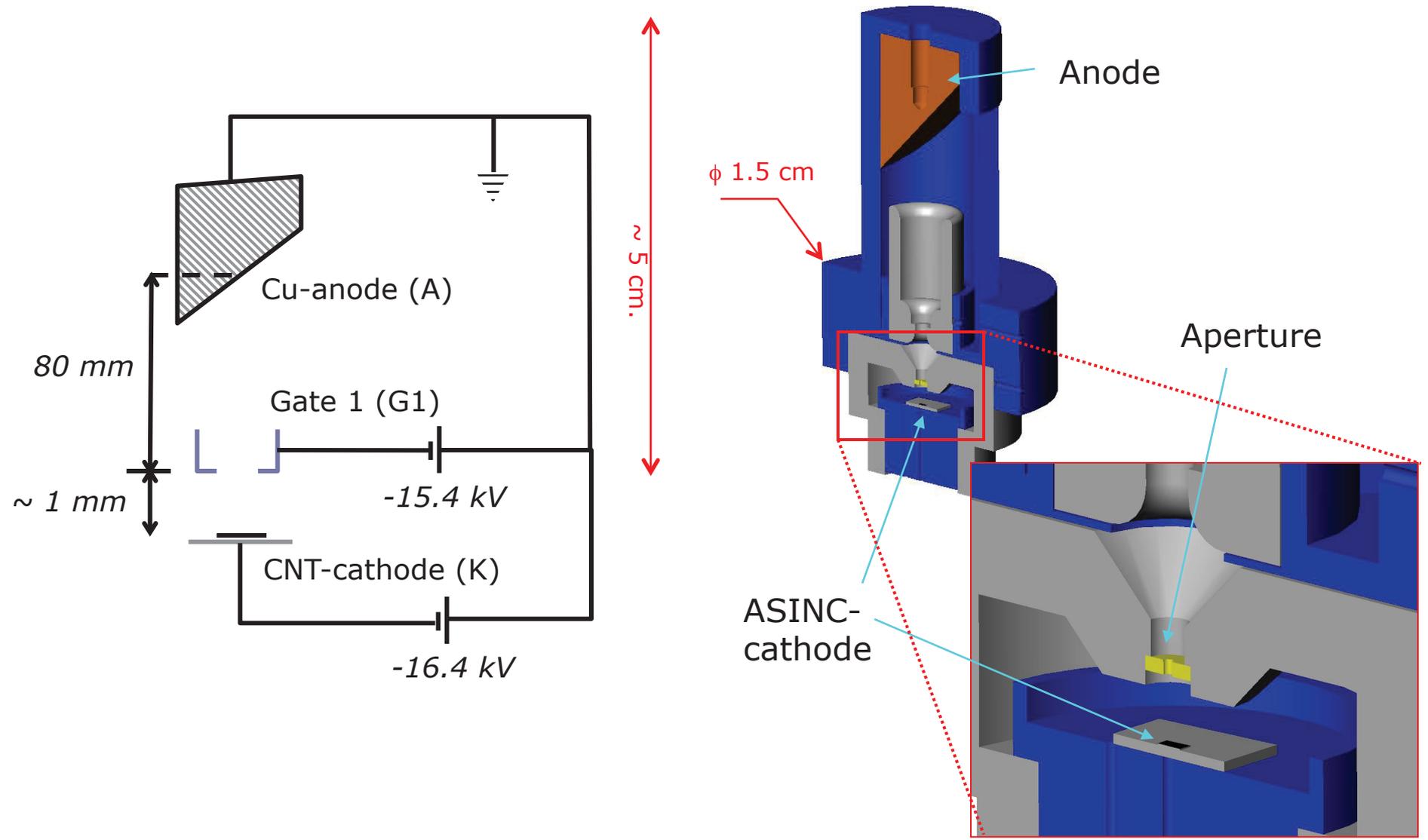
## Why CNTs?

- **No heater:** Save on power, mass, volume
- **Small source:** Easier focusing >> Smaller spot size >> Sharper diffraction patterns
- **Lower Voltage of Operation:** 15 kV in stead of 30 to 50 kV! {*lower arcing probability*}
- **Higher current density helps** >> Faster data collection (only detector speed limited)
- **Especially important on Venus** where shorter integration times would be required (mission life would be in hours).

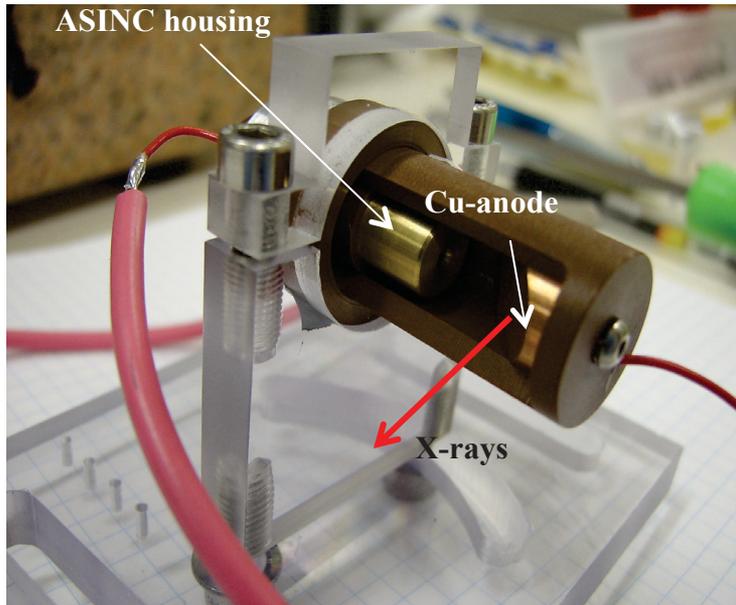


# APPLICATIONS: X-rays for Mineralogy

## CNT X-ray Tube



## CNT X-ray Tube



- Uses shaped **Cobalt or Copper** anode
- CNT bundle arrays are mounted on a screw-on platform
- Electron optics not optimized
- Operates between **15 kV to 20 kV** acceleration voltage
- Emitted current at the cathode is in the range of **15  $\mu$ A to 50  $\mu$ A**
- Max. photon flux produced so far  **$\sim 8.8 \times 10^4$  /s** (1-mm  $\phi$  aperture)

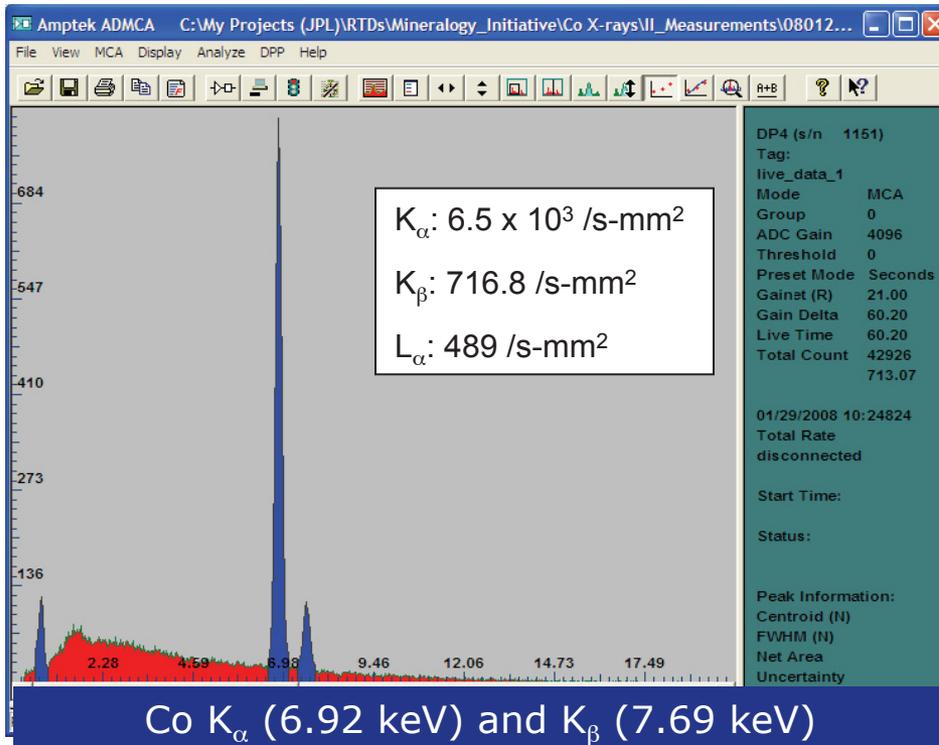
### Emission Efficiency

$$\eta = I_A / I_K$$

# APPLICATIONS: X-rays for Mineralogy

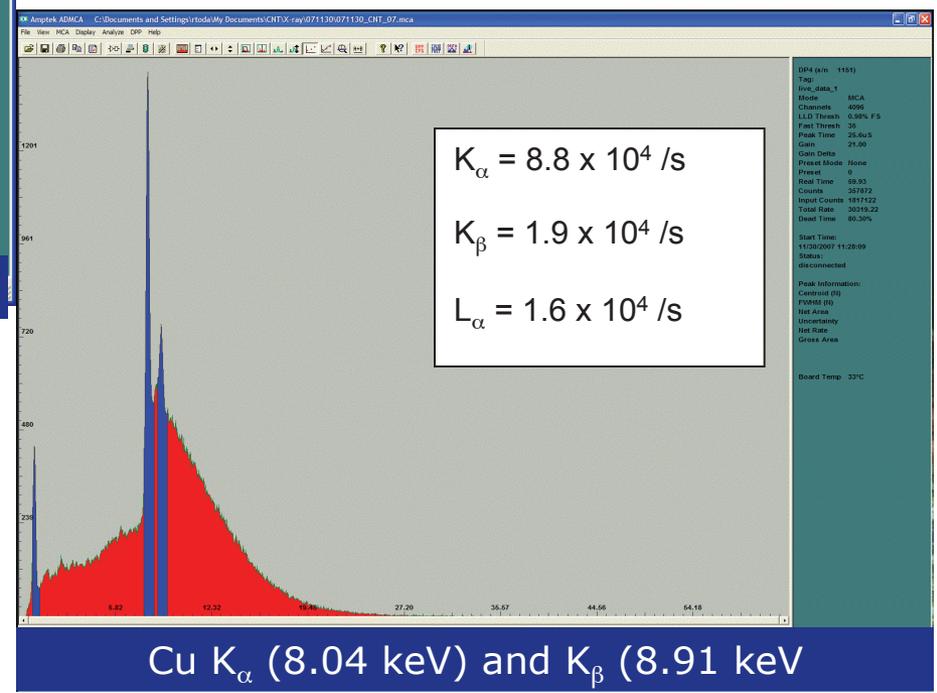


## CNT X-ray Tube



$I_A \sim 3 \mu\text{A}$  ( $\eta \sim 20\%$ );  $V_A \sim 20.0$  kV;  $V_G = 2$  kV; Measured photon fluxes through a 200- $\mu\text{m}$   $\phi$  collimator are shown in the inset.

$I_A \sim 15 \mu\text{A}$  ( $\eta \sim 30\%$ );  $V_A \sim 16.4$  kV; Measured photon fluxes through a 1-mm  $\phi$  collimator are shown in the inset.



Cu  $K_{\alpha}$  (8.04 keV) and  $K_{\beta}$  (8.91 keV)

# APPLICATIONS: 700° C Logic Gates

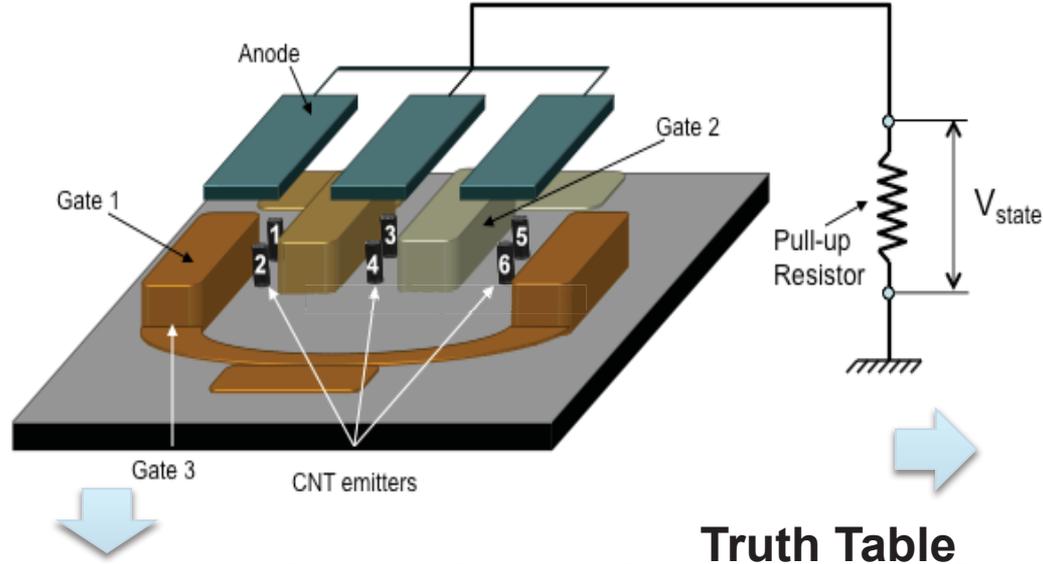


- To fulfill the need for extreme environment electronics (700° C and radiation insensitive or hard)
- State-of-the-art: Solid-State devices; demonstrated up to 500° C and tens of Mega Rads (limited component demonstrations).
- NEMS computational components demonstrated up to 600° C (Case Western).
- JPL technology: “Digital” Vacuum Microelectronics – *programmable logic gate demonstrated at 700° C (DC switching)*
  - Turning the “clock” back a “bit” to the tube days; merging micromachining, nanotube field emission and vacuum packaging techniques.
- **FIRST OF ITS KIND** device demonstrated under a DARPA Seedling.

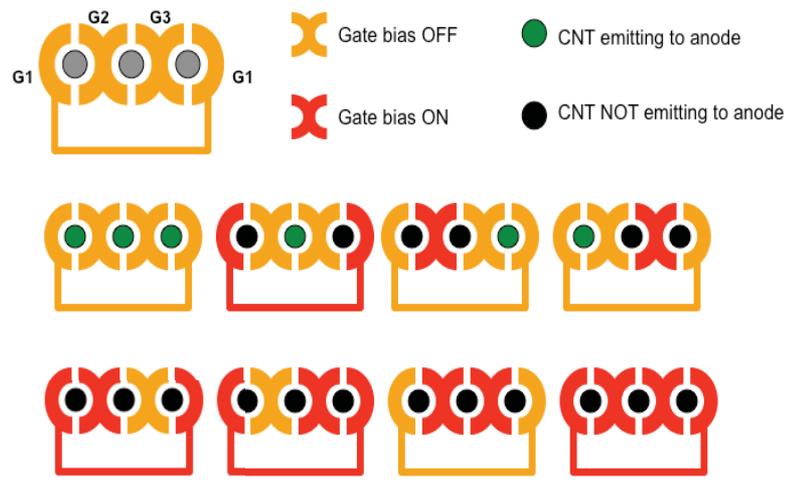
# APPLICATIONS: 700° C Logic Gates



## Inverse Majority Gate Device Schematic



## Operational Schematic

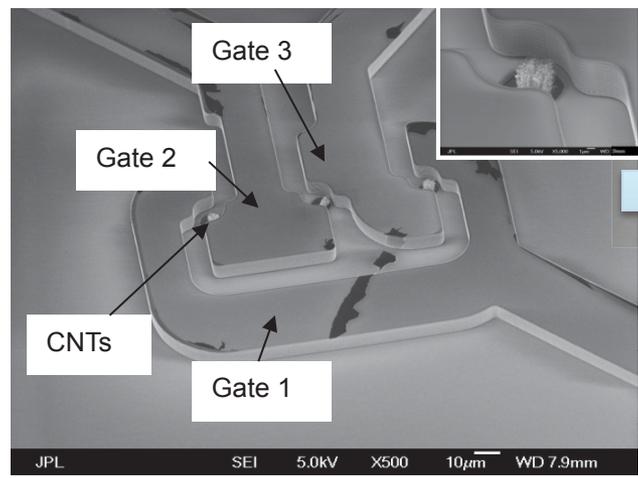


## Truth Table

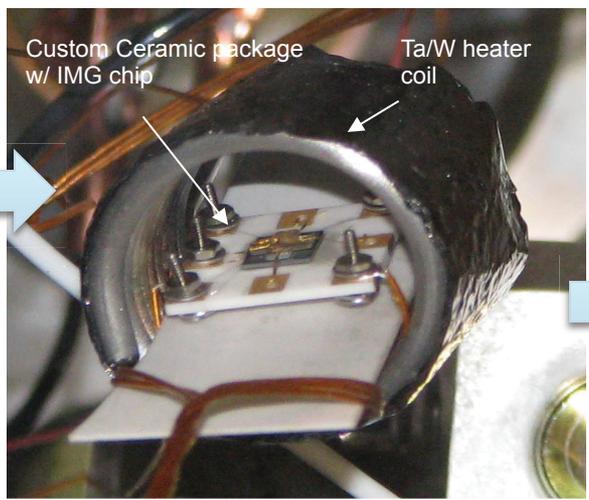
Number of Logic States	Gate 1	Gate 2	Gate 3	Output
1	0	0	0	1
2	0	0	1	1
3	0	1	0	1
4	0	1	1	0
5	1	0	0	1
6	1	0	1	0
7	1	1	0	0
8	1	1	1	0

Combination of **NAND** and **NOR** gates

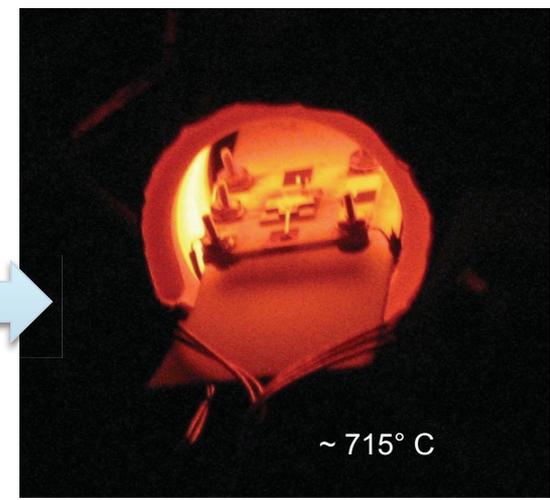
# APPLICATIONS: 700° C Logic Gates



IMG Device-SEM micrograph



IMG inside a Ta/W Coil



Device Under Test

## Three-Gate Operation

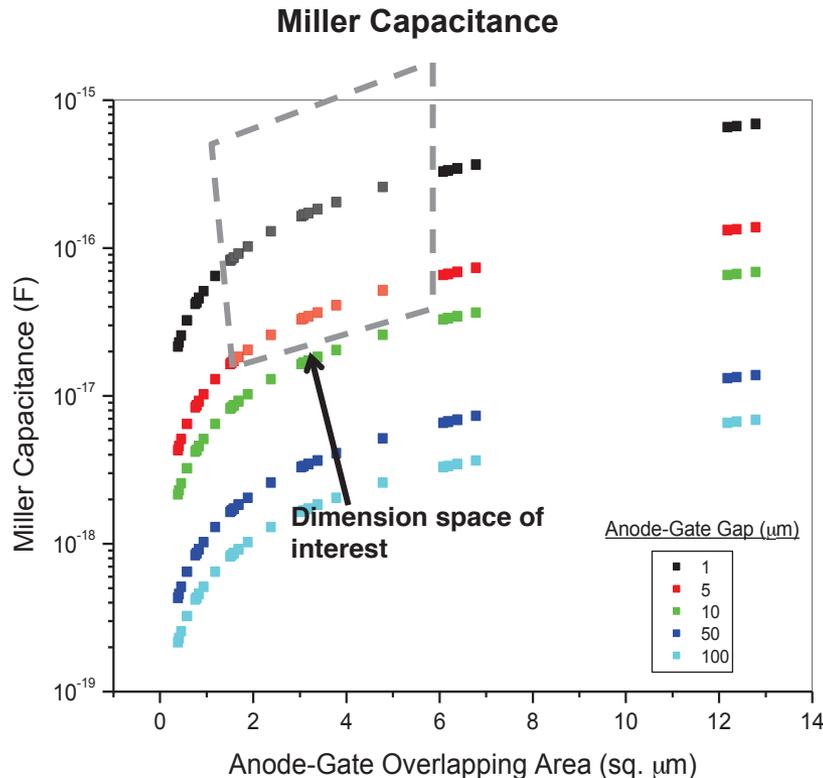
V <sub>a</sub> (V)	V <sub>g1</sub> (V)	V <sub>g2</sub> (V)	V <sub>g3</sub> (V)	I <sub>a</sub> (nA)	O/P State
50	0	0	0	3.2	1
50	10	0	0	2.8	1
50	10	10	0	0.7	0
50	10	10	10	0	0
50	0	10	0	3.6	1
50	0	10	10	0.27	0
50	0	0	10	2.5	1
50	10	0	10	0.35	0

# APPLICATIONS: 700° C Logic Gates



For a Full Adder	Solid State (0.18 μm process)	Solid State (0.09 μm process)	IMG-based (0.5 μm process)
Footprint (μm)	13.86 x 5.4	8.12 x 2.52	18 x 4

- Traditional vacuum tubes operate at 1300° to 1500° C, so are natural choices for high-temperature electronics.
- Device can be designed for smaller footprint
- Switching frequency- 10-100 GHz possible; *limited only by the K-A electron transit time*
- Low level current (tens of nA) operation ensures long operational lifetime (10,000 hours tested for CNT flat panel displays).
- CNT emission more stable at 700° C (<1% variation tested).



# SUMMARY



- Carbon nanotube bundle arrays have been made to realize field emission sources for high current density applications.
- These sources act as the fundamental components of miniature analytical devices and vacuum microelectronics.
- Some applications such as a miniature X-ray tube, and “digital” vacuum electronics for high temperature applications have been developed.



# **DISTRIBUTED CAPACITOR (DISC) SENSOR FOR SAMPLE VERIFICATION**

**Sample verification sensors would be needed to ensure success of robotic sample return missions.**

# NEED: Past Sample Return Missions



Human Missions:  
Sample collected and  
verified by astronauts



RS12-47-6934

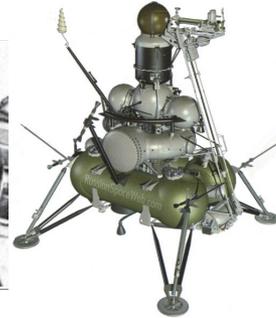


Apollo mission sample  
collection case  
(1969-1972)

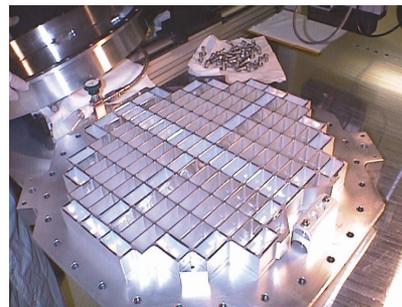
Unmanned Robotic Missions:  
Sample quantity verified only after return to Earth



Russian *Luna-24*  
sample collector  
(Launched 1976)



JAXA's *Hayabusa* re-  
entry vehicle (Launched  
2003)



*Stardust* Aerogel sample  
collector (Launched  
1999)

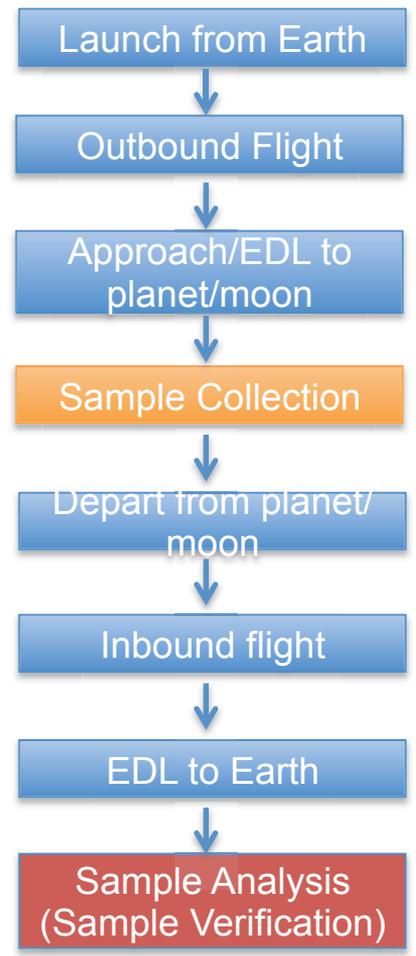


*Genesis* solar wind  
particles collector  
(Launched 2001)

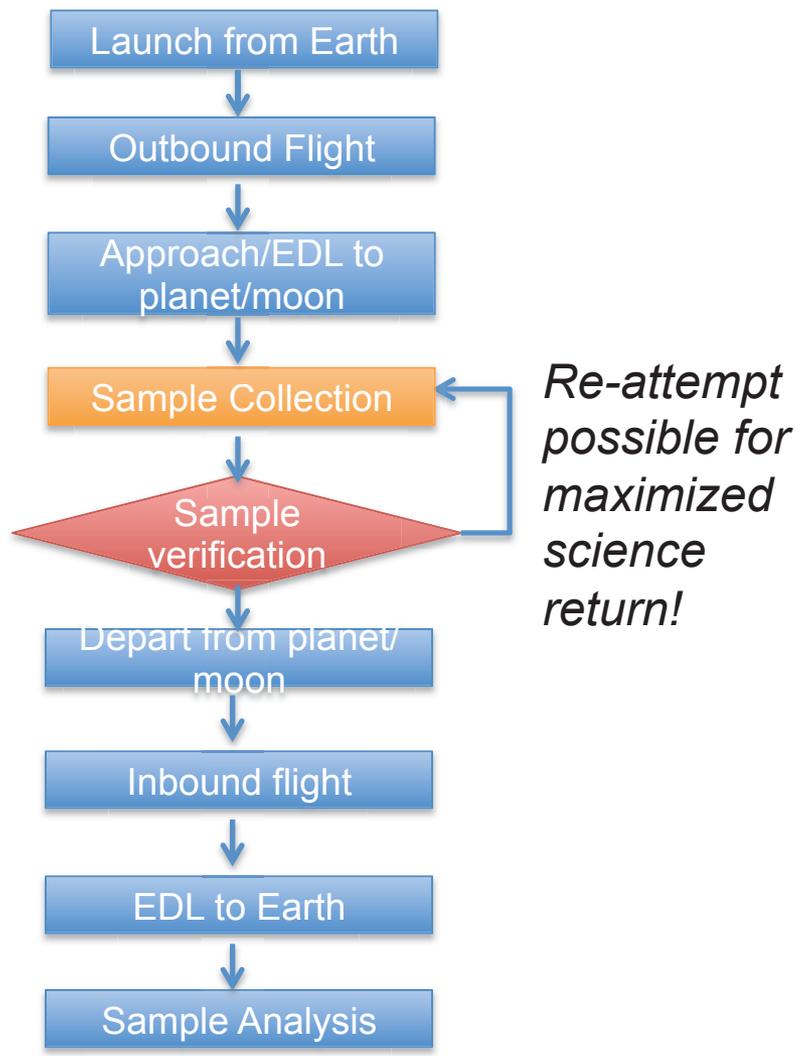
# NEED: SVS would maximize science return



## Previous Unmanned Planetary Sample Return Missions

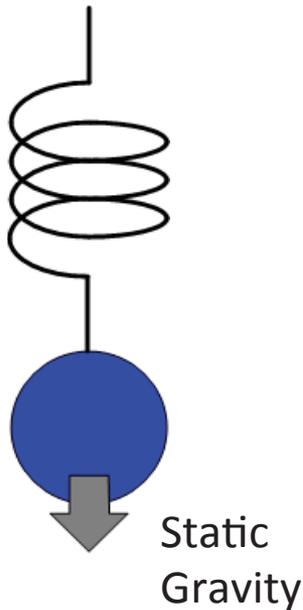


## Sample Return Missions with Sample Verification



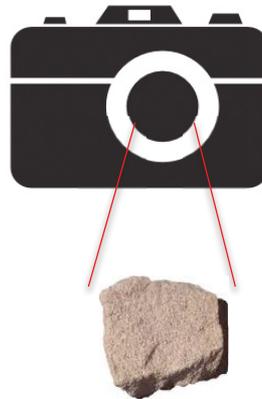
# Possible Sample Verification Methods

## Spring-Mass Method



- Relatively simple
- Requires gravity (not applicable to Asteroid)

## Optical Imaging Method

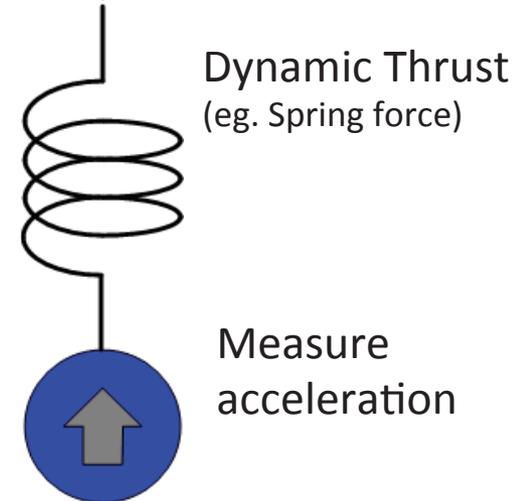


- Color and shape observed
- Lens may be obscured by dust
- Mass not measurable

## Inertia Method (Newton's 2<sup>nd</sup> law of motion)

$$F = m \frac{dv}{dt}$$

*Used on ISS for astronaut weight measurement  
Space Linear Acceleration Mass Measurement  
Device (SLAMMD)*



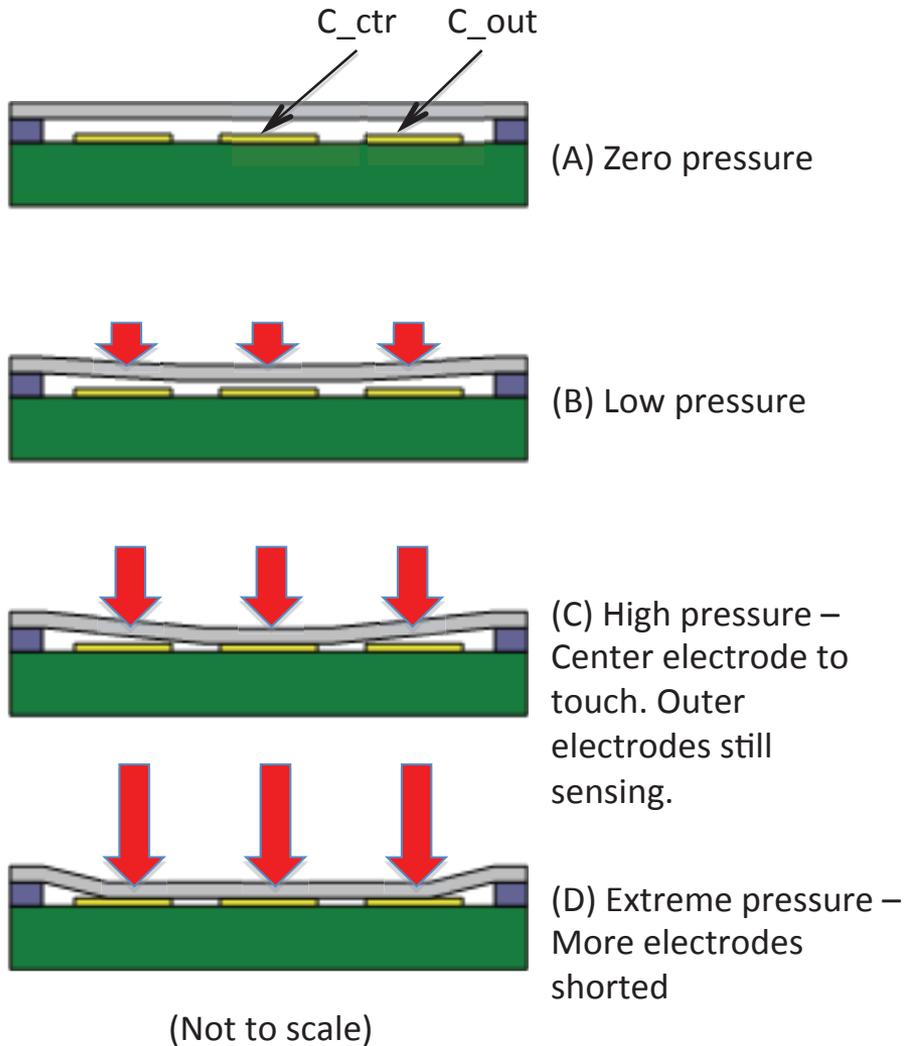
- Applicable to Asteroid (microgravity)
- Requires dynamic thrust

# Sample Verification System (SVS) Requirements



- Contamination issues
  - Even small contamination could impact isotopic age determination.
  - All surfaces that may touch sample must be made with proven materials. Only few materials such as SUS304 and AL6061 would be allowed.
  
- Harsh environment
  - Survival temperature, -95C to +60C on moon.
  
- Measurement accuracy / range
  - Measure 50g +/-10g in lunar gravity.
  - Range 1000~3000g.
  
- Robustness
  - Launch and EDL shock tolerance
    - Vibration 10~60G.

# Distributed Capacitance (DisC) Sensor Concept



- Elastic membrane and rigid substrate forms variable (semi-) parallel plate capacitor.

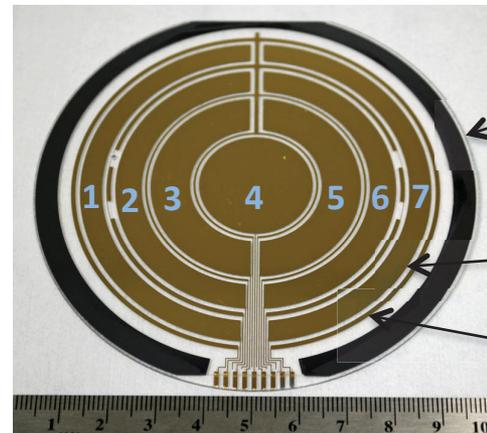
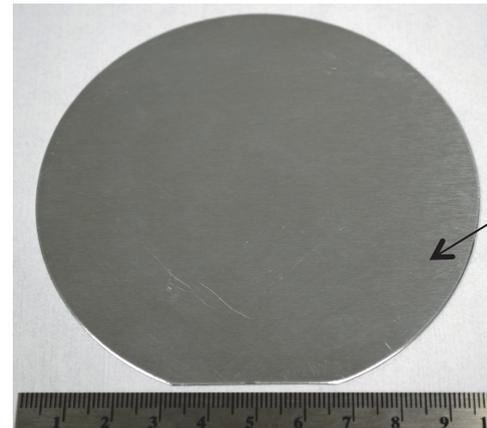
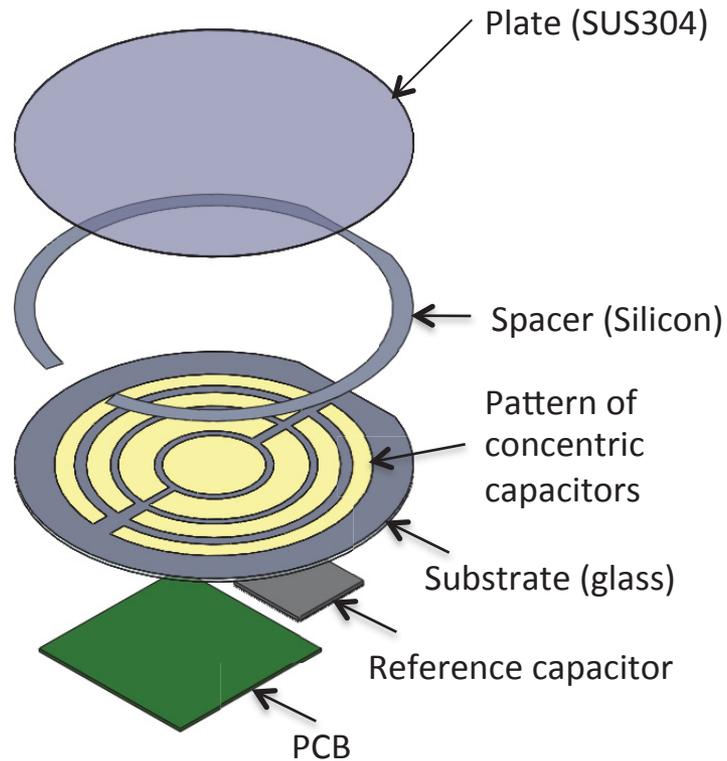
- Capacitance is inversely proportional to gap distance.

$$C = \epsilon \frac{A}{d}$$

- As sample accumulates, elastic membrane deforms and capacitance increases.

- Robustness: When excessive weight/shock is applied, elastic membrane is stopped/protected by rigid substrate

# SVS DisC Sensor: First Prototype



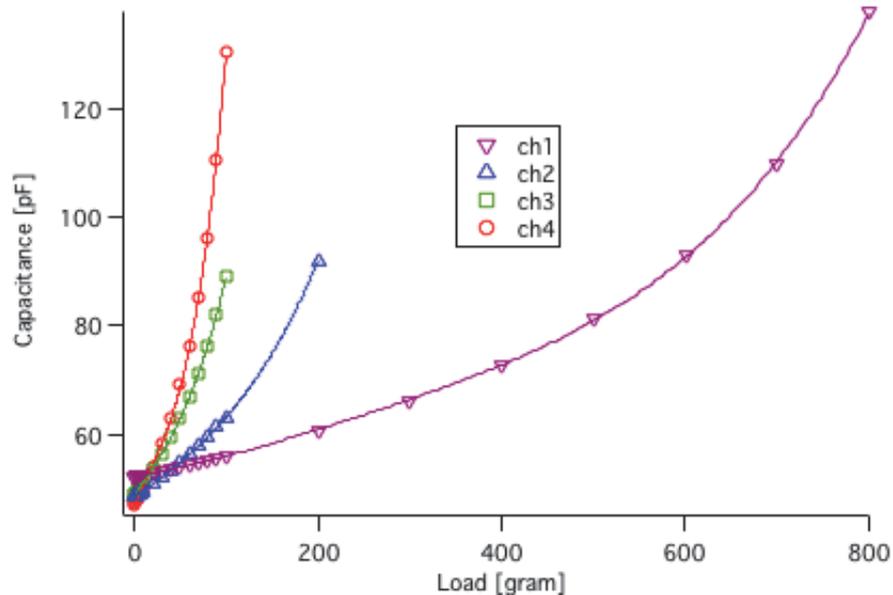
## Issues with first prototype:

- Observed thermal drift due to CTE mismatch.
- Front-to-back wiring deemed weak.

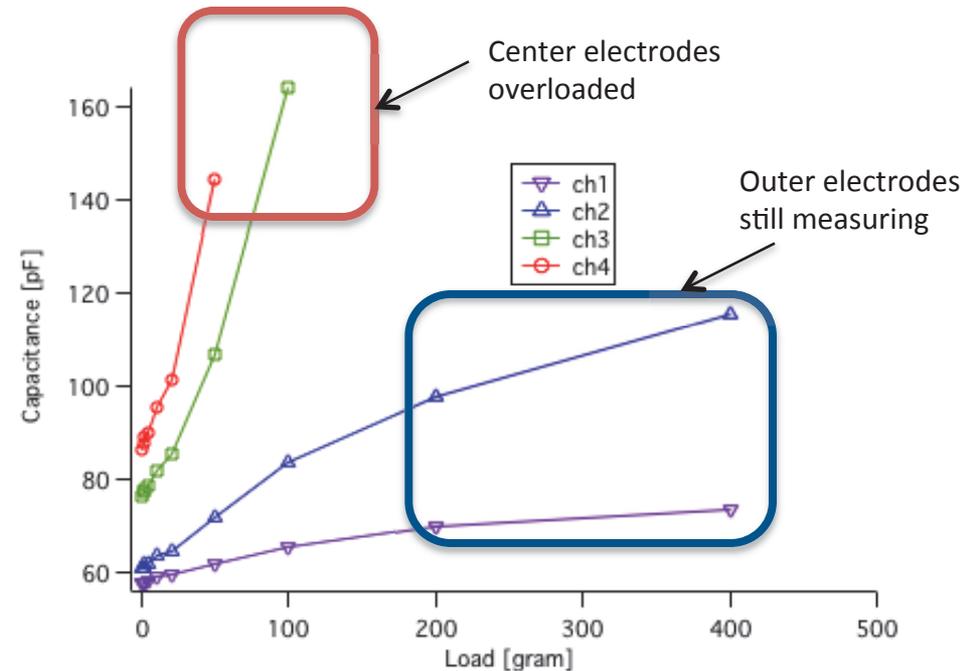
## Fabrication method

1. Silicon/glass anodic bonding
2. DRIE Silicon
3. Evaporate electrode pattern

# Simulation vs. Experiment



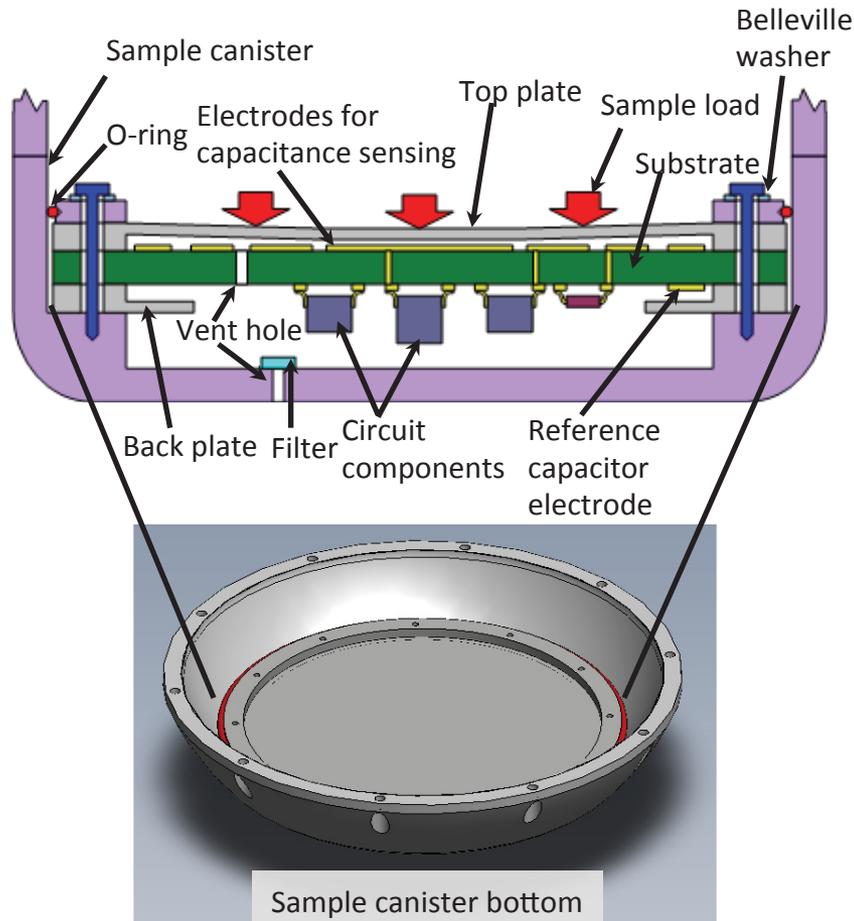
FEM simulation



Experimental result  
(Uniform loading with BB pellets)

- Once center channel touch, the rate of increase slows at outer channels.
- This is because top plate and electrode contact is not simulated.
- Otherwise, the behavior looks similar.

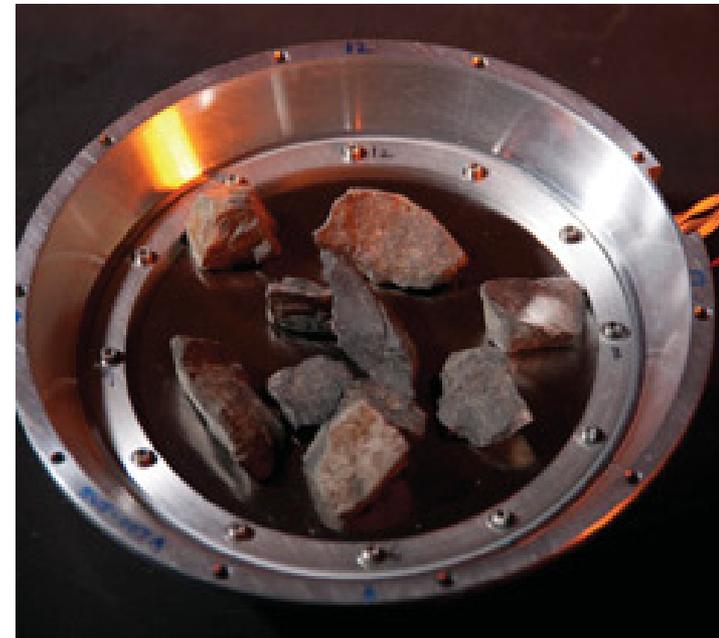
# SVS DisC Sensor: Second Prototype



(Cross-sectional view is not to scale)

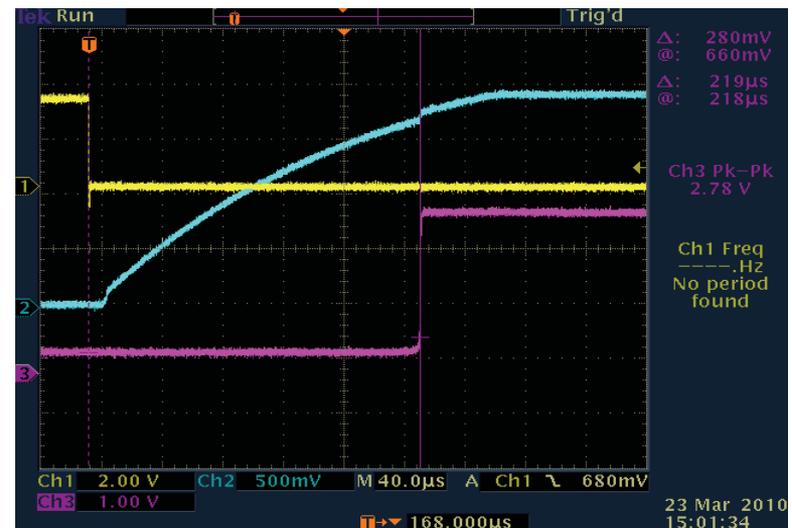
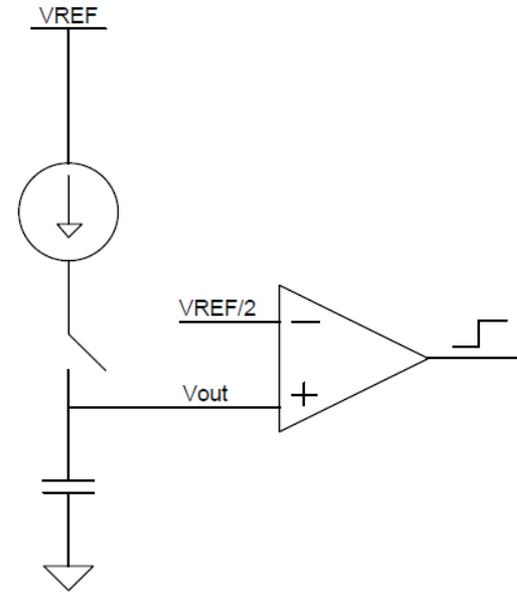
## Improvements over first prototype

- Use Polyimide PWB as substrate:
  - Distributed capacitor electrodes on top side
  - Circuit components on bottom side
- CTE mismatch absorbed by allowing plates to slip
- Use more flight-approved components

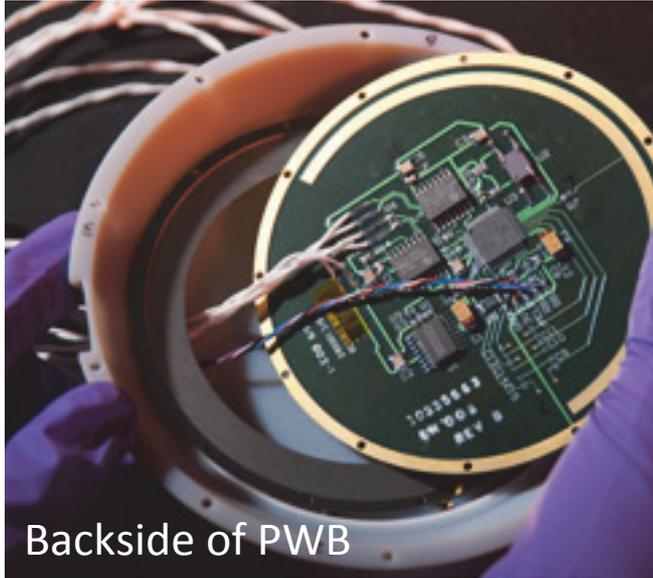


# Electronics: How it works

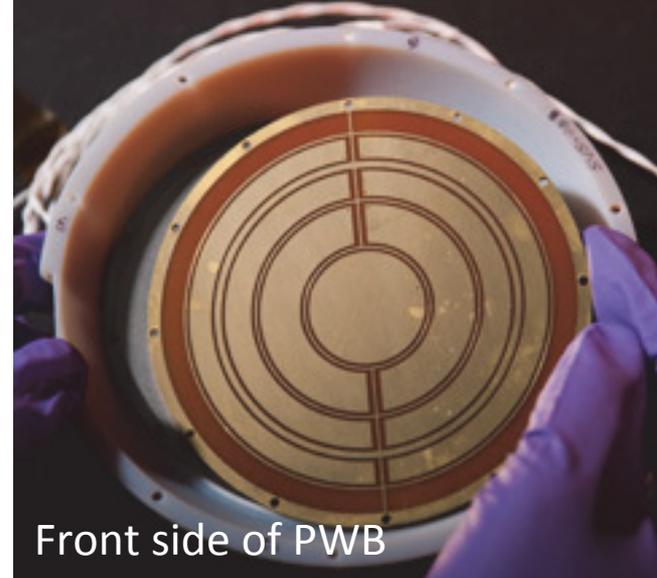
- Current source charges selected SVS capacitive electrode
- Voltage on capacitor compared against reference with comparator
- Microcontroller counts charge time for capacitive measurement



# Second Prototype Assembly



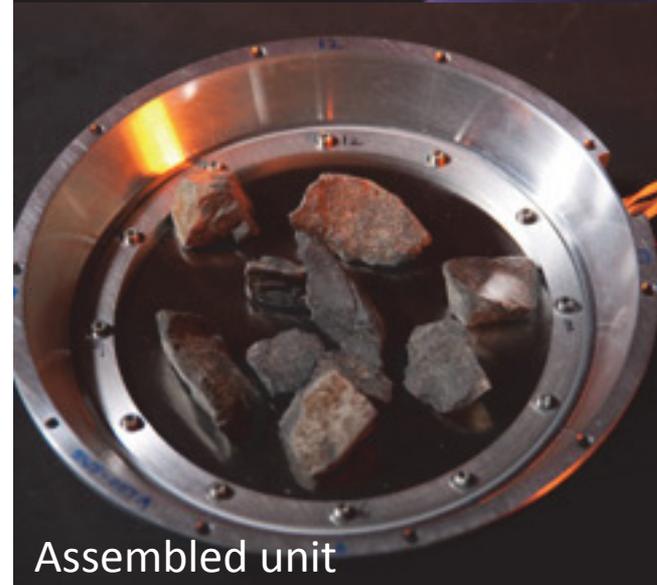
Backside of PWB



Front side of PWB

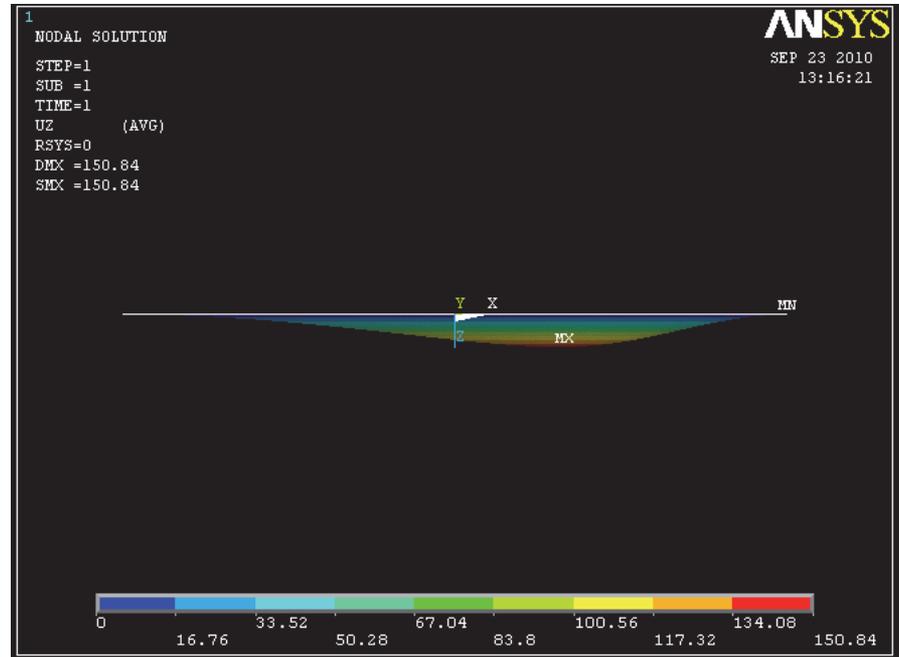
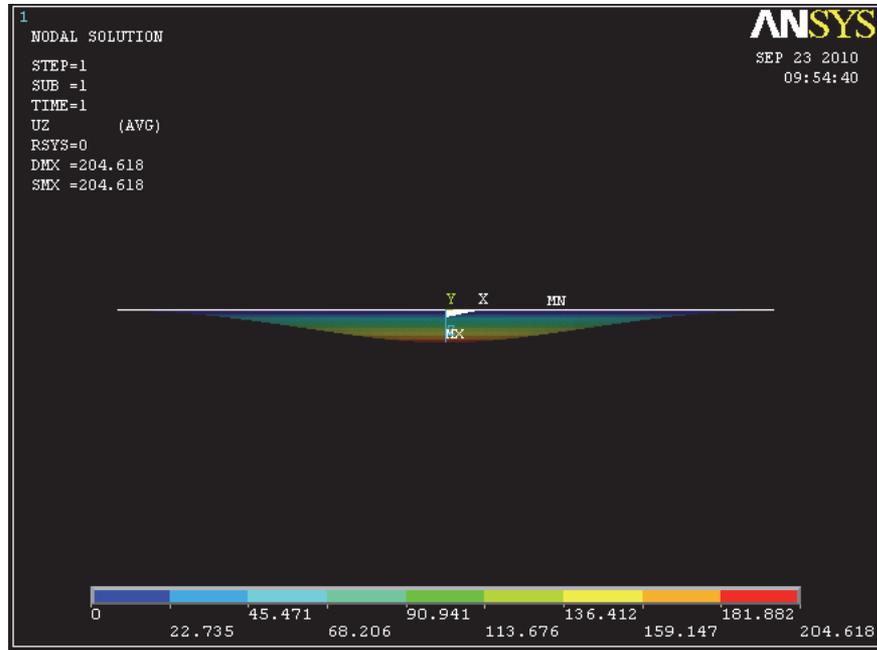


SUS304 Top plate is placed



Assembled unit

# Non-Uniform Loading



100g weight (20mm diameter footprint) placed at center

100g weight (20mm diameter footprint) placed 20mm off-center

(z-axis scaling is exaggerated)

- **Localized load may cause measurement error.**
- **Statistical approach coupled with robotic arm agitation to minimize measurement error (shown next page).**

# Sensor Calibration with Rock

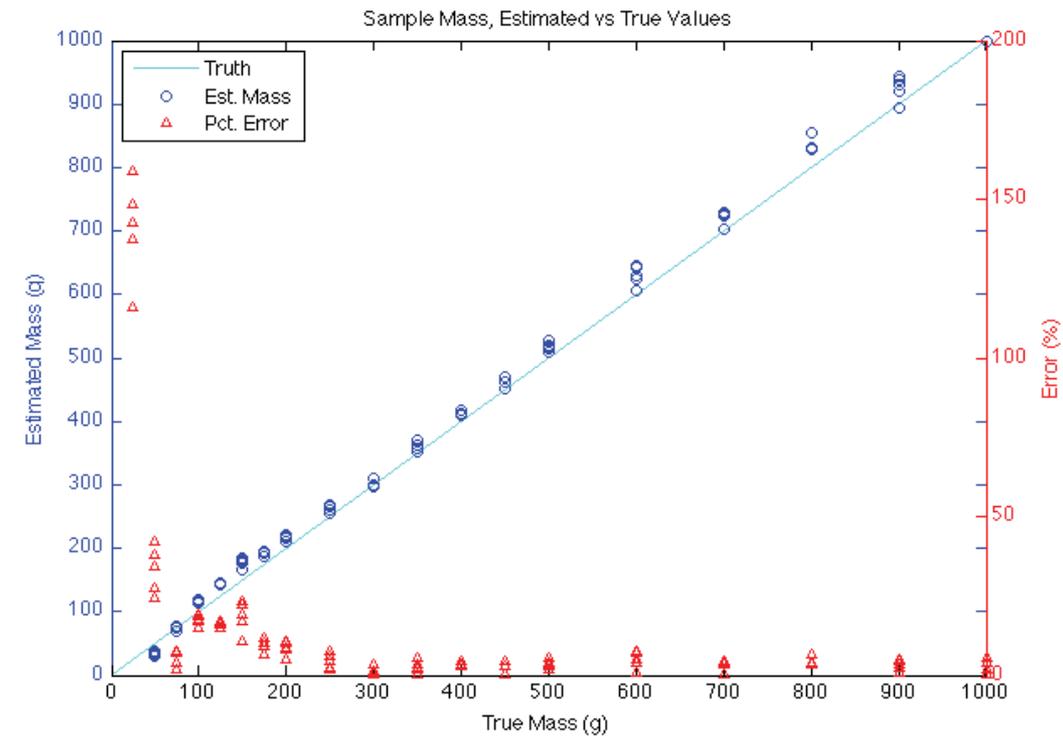


Plate thickness 300um  
Initial gap width 200um

- Repeated test with canister agitation provides improved measurement accuracy.

# Summary



- Proof-of-principle sample verification system (DisC sensor) developed for Lunar sample return missions.
- Sensor designed for harsh environment and robustness.
- Sensitivity depends on plate thickness and initial gap width: typ. 0.1~1pF/gram
- Calibration with rock sample showed good statistical accuracy.
- Environmental tests (Thermal vacuum, shock, etc.) planned.



**Thank You!**